

Sheet 1 of 1								INFORMATION DISCLOSURE STATEMENT							
FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Date Submitted to PTO: September 23, 2005				ATTY DOCKET NO. 2005_1513A		SERIAL NO. NEW 10/549849									
				APPLICANT Jyun IWASHITA				IC20 Rec'd PCT/PTO 23 SEP 2005							
				FILING DATE September 23, 2005				GROUP 1795							
U.S. PATENT DOCUMENTS															
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE								
/P.T.R./	AA	6,432,615	08/2002	Nakamura et al.	430	281.1	3/31/2000								
/P.T.R./	AB	6,395,453	05/2002	Kaneko et al.	430	281.1	2/28/2000								
/P.T.R./	AC	2001/0049073	12/2001	Hada et al.	430	270.1	5/29/2001								
/P.T.R./	AD	6,063,543	05/2000	Hien et al.	430	270.1	4/26/1999								
/P.T.R./	AE	6,306,990	10/2001	Hien et al.	562	272	4/26/1999								
	AF														
	AG														
FOREIGN PATENT DOCUMENTS															
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO								
/P.T.R./	AH	2001-247513	09/2001	JP			abstract								
/P.T.R./	AI	2001-166474	06/2001	JP			abstract								
/P.T.R./	AJ	2000-284473	10/2000	JP			corresponds to AA								
/P.T.R./	AK	2000-250204	09/2000	JP			corresponds to AB								
/P.T.R./	AL	2000-206694	07/2000	JP			corresponds to AC								
/P.T.R./	AM	2000-75486	03/2000	JP			corresponds to AD								
/P.T.R./	AN	2000-56459	02/2000	JP			abstract								
/P.T.R./	AO	2000-26548	01/2000	JP			corresponds to AE								
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)															
	AP														
	AQ														
EXAMINER				/Ponder Thompson Rummel/				DATE CONSIDERED				10/15/2007			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include cop. this form with next communication to applicant.

12/12/05

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary) Date Submitted to PTO: December 12, 2005				ATTY DOCKET NO. 2005_1513A		SERIAL NO. 10/549,849		APPLICANT Jyun IWASHITA et al.	
				FILING DATE September 23, 2005		GROUP 1795			
U.S. PATENT DOCUMENTS									
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	AA								
	AB								
	AC								
	AD								
	AE								
	AF								
	AC								
	AH								
	AI								
FOREIGN PATENT DOCUMENTS									
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO		
/P.T.R./	AJ	8-3635	01/1996	JP			partial		
	AK								
	AL								
	AM								
	AN								
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)									
/P.T.R./	AO	Tsuchiya, Y. et al., "Investigation of Acid-Catalyzed Insolubilization Reactions for Alicyclic Polymers with Carboxyl Groups", <i>Journal of Photopolymer Science and Technology</i> , Vol. 10, No. 4, pp. 579 to 584 (1997).							
/P.T.R./	AP	Maeda, K. et al., "ArF Chemically Amplified Negative Resist Using Alicyclic Epoxy Polymer", <i>Journal of Photopolymer Science and Technology</i> , Vol. 11, No. 3, pp. 507 to 512 (1998).							
/P.T.R./	AQ	Iwasa, S. et al., "Novel negative photoresist based on polar alicyclic polymers for ArF excimer laser lithography", <i>SPIE</i> , Vol. 3333, pp. 417 to 424 (1998).							
EXAMINER				DATE CONSIDERED					
/Ponder Thompson Rummel/				10/11/2007					

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FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) <i>(Use several sheets if necessary)</i> Date Submitted to PTO: March 26, 2007			ATTY DOCKET NO. 2005_1513A APPLICANT Jyun IWASHITA et al			SERIAL NO. 10/549,849 FILING DATE December 12, 2005 GROUP 1795		
U.S. PATENT DOCUMENTS								
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
/P.T.R./	AA	2002/0058197	5/2002	Nozaki et al.	430	270.1	8/24/2001	
/P.T.R./	AB	6,506,534	1/2003	Nozaki et al.	430	270.1	9/1/2000	
/P.T.R./	AC	2001/0003640	6/2001	Takechi et al.	430	270.1	12/19/2000	
	AD							
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	AF							
	AG							
	AH							
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